



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Toshimitsu HIRAI

Application No.: 10/803,027

Docket No.: 119152

Filed: March 18, 2004

For: METHOD OF FORMING THIN FILM PATTERN, METHOD OF
MANUFACTURING DEVICE, ELECTRO-OPTICAL APPARATUS AND
ELECTRONIC APPARATUS

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,

James A. Oliff
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JAO:EDM/emt

Date: October 5, 2004

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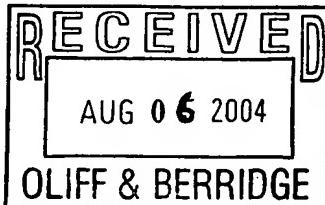
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/803,027	03/18/2004	770		119152	13	1 22	1 2

25944
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CONFIRMATION NO. 5610

FILING RECEIPT



OC000000013441198

Date Mailed: 08/05/2004

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Applicant(s)

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Assignment For Published Patent Application

SEIKO EPSON CORPORATION, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2003-098274 04/01/2003
JAPAN 2004-070834 03/12/2004

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Method of forming thin film pattern, method of manufacturing device, electrooptical apparatus and electronic apparatus
electro-optical

Preliminary Class

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Title 35, United States Code, Section 184
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